



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

April 25, 2026

IGI Report Number

LG792611871

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

OVAL BRILLIANT

Measurements

8.71 X 5.58 X 3.35 MM

GRADING RESULTS

Carat Weight

1.04 CARAT

Color Grade

E

Clarity Grade

VVS 2

Cut Grade

VERY GOOD

ADDITIONAL GRADING INFORMATION

Polish

VERY GOOD

Symmetry

VERY GOOD

Fluorescence

NONE

Inscription(s)

 LG792611871

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

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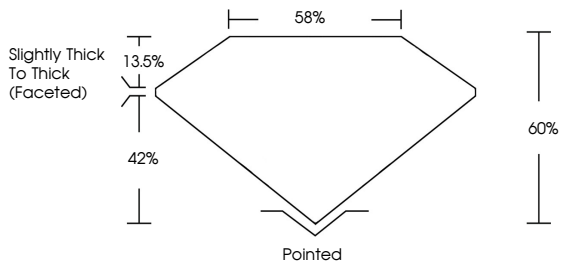
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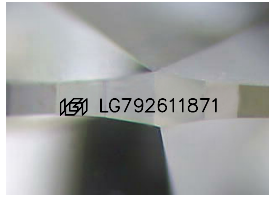
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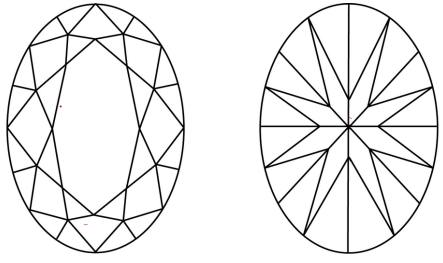
PROPORTIONS





Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS 1-2 VS 1-2 SI 1-2 I 1-3

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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IGI

April 25, 2026

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OVAL BRILLIANT

8.71 X 5.58 X 3.35 MM

Carat Weight

1.04 CARAT

Color Grade

E

Clarity Grade

VVS 2

Cut Grade

VERY GOOD

Depth

60%

Table

88%

Graile

Slightly Thick To Thick (Faceted)

Culet

Pointed

Polish

VERY GOOD

Symmetry

VERY GOOD

Fluorescence

NONE

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